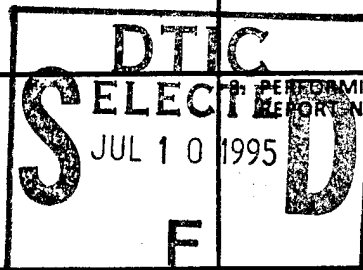


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## 13. ABSTRACT (Maximum 200 words)

Our previous work emphasized energy deposition in ultra-thin films in the projectile energy regime near and above the stopping maximum. Not only are most stopping measurements done in that regime, but the theory is simplified under this assumption, since Bethe stopping is dominant. Thus, we have developed, demonstrated the effectiveness, and applied an approximate model which works well in this energy domain. We have predicted a number of ultra-thin film effects which await experimental verification and technological exploitation.

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# Theoretical and Numerical Prediction of Stopping Properties of Counterpart Thin Films and Solids

Final Report

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May 30, 1995

U.S. Army Research Office

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## 1. Statement of the Problem

Our previous work emphasized energy deposition in ultra-thin films in the projectile energy regime near and above the stopping maximum. Not only are most stopping measurements done in that regime, but the theory is simplified under this assumption, since Bethe stopping is dominant. Thus, we have developed, demonstrated the effectiveness, and applied an approximate model which works well in this energy domain. We have predicted a number of ultra-thin film effects which await experimental verification and technological exploitation.

Recently the technological challenge has shifted from high-energy projectiles (e.g. weapons effects) to lower energy exposures characteristic of such diverse environments as ion-implantation apparatus and satellite-mounted electronics. In such environments, the combination of ultra-thin materials films and low projectile energies is relatively unexplored. As we show below, we have most of the tools and techniques which need to be combined to address that family of important problems.

To give but one of several possible examples, large fluxes of low-energy ions and thin film technology have come together as a challenge to providing stable micro-electronic components in satellites and space vehicles. Although not as big a problem for now in large, earth-bound machines (in which redundancy and both hard and software bitchecking are normal since mass and volume are not such critical engineering limitations), issues of single-event upsets are a concern for weight-limited devices in high flux, but relatively low energy, radiation fields such as occur when electronics are flown. *Such problems become more severe inversely with system size.* Similarly, thin film technology has improved dramatically in recent years. It is now possible to make free-standing films (not overlayers!) routinely on the order of 25 Å. Such films, of the order of ten monolayers (e.g. carbon), may be supported on a macroscopic grid, but are, for all intents and purposes, free standing.

## 2. Summary of Results

Progress and accomplishments during 1991-95 (first half) are conveniently divided into four categories:

1. Conception, implementation, testing and first applications of the **CHANNEL** code,
2. Continued development of the **FILMS** and **FILMSTOP** codes and their application to studies of the electronic structure and stopping properties of significant thin film systems,
3. Study and calculation of the stopping properties of several important molecular systems, and
4. implementation of the generalized oscillator strength (GOS) formulation of the first Born approximation stopping, with demonstration of the severity of the current practical limits on state-of-the-art, fully *ab initio* GOS calculations.

Papers cited in this section are listed in the section headed "Papers Acknowledging Support from the Present Contract Period." We consider each of the four topics briefly.

1. Perhaps the most dramatic advance has taken place over the past two years, in which we have worked out the theory, design, and coding of the program **CHANNEL**, which calculates trajectories for low energy ions,  $E \approx 25 \text{ keV}$ , in bulk solids. The simulation relies upon

realistic, quantum mechanically derived charge densities, potentials, and dissipative forces in describing the interaction of the projectile (thus far restricted to protons) with the bulk solid target. As described in detail below, **CHANNEL** solves the classical equations of motion for the projectile in the solid. The solution enables prediction of the penetration depths and range straggling (ion implantation profiles) as well as observation of the channeling behavior of the incident ions.

The design assumptions of the code are intended to yield better (in the sense of including more of the essential physics) results than previous codes such as the Monte Carlo codes, **MARLOWE**, **TRIM**, **BCCRY**, **PEPPER**, **BABOUM** and **LAROSE**. In particular these tend to treat the scattering of the incident ions by the crystal lattice as binary collisions using screened atomic-like potentials. The dissipation force used includes, in an approximate way, both electronic and nuclear energy dissipation terms. Some programs, such as **TRIM** and **BABOUM**, treat the target as an amorphous or random solid. However, **TRIM** can do calculations of various compounds which have up to 3 layers of differing materials.

**CHANNEL** appears to be the first code which uses a potential and charge density generated from a quantum mechanical crystalline calculation. To keep simulation times within reason, the calculation of ion implantation profiles must be for ions of relatively modest incident energy (of the order tens of keV) simply to allow the ion to be trapped in the target within some reasonable distance. Thus, by the nature of the problem, the ion's trajectory will be influenced strongly by the potential with which it interacts. This means that a method for calculating accurate ion implantation profiles must have a very realistic representation of the crystalline potential as well as the dissipative force. The dissipation function developed by Echenique *et al.* which we use, is particularly suited for low energy ions. It expresses the energy dissipation term as a function of the local electronic density, hence allows realistic determination of the dissipative force from the solid's electronic charge density.

Testing the code involved examining protons channeling in simple cubic hydrogen, a particularly instructive and transparent case since the channel geometry (symmetry) is such that one can check the results for reasonableness by inspection and hand calculation. After debugging, we generated hypothetical ion implantation profiles for protons in the  $\langle 100 \rangle$  channel. (Experimental data on solid atomic H are, of course, unavailable.)

A more realistic and technologically interesting case is protons in silicon. We simulated the implantation profiles of low energy protons in the  $\langle 110 \rangle$  and  $\langle 100 \rangle$  channels of Si in the diamond structure [space group  $Fd\bar{3}m-O_h^7$ , diamond Si]. Although the calculations are expensive in terms of computer time (the program is yet to be optimized), the preliminary results are very encouraging. To determine a well-defined average penetration depth would require more trajectories, but it appears that a reasonable average depth is emerging. The results also indicate that the range in the  $\langle 110 \rangle$  channel should be nearly 3 times that in  $\langle 100 \rangle$ , as shown in Figure 1.

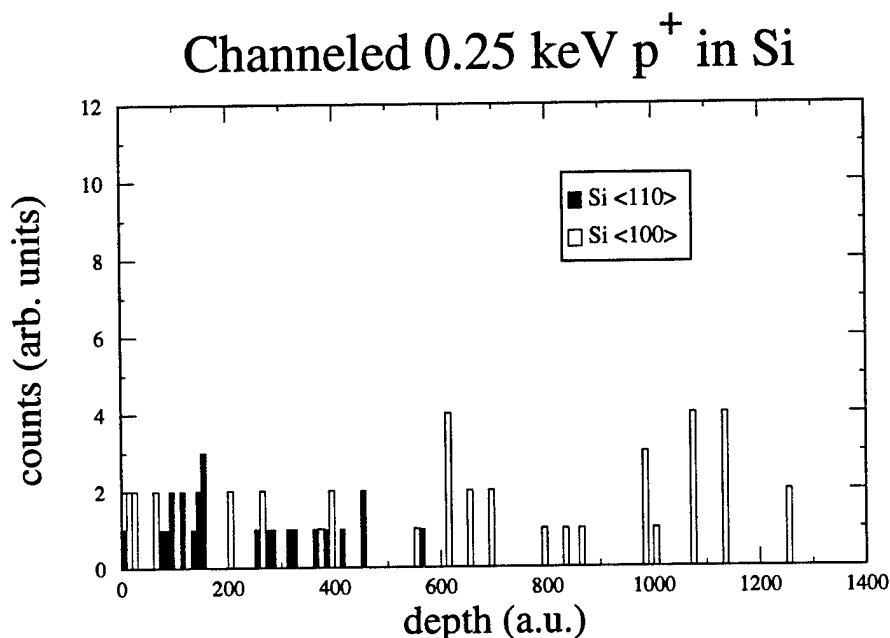


Figure 1: Deposition profiles for 0.25 keV protons in the  $\langle 110 \rangle$  (open) and  $\langle 100 \rangle$  (filled) channels of diamond Si

Clearly the method has great promise for predicting and interpreting the channeling behavior of low energy ions ( $E$  in the tens of keV) in extended systems. These results are new enough that they have not been published yet, but a preliminary version of the channeling of protons in hydrogen in the simple cubic structure (scH) has been submitted (paper #19).

2. The second major accomplishment was the use of the **FILMS** and **FILMSTOP** codes for large-scale study of the electronic structure and stopping of several ultrathin films. Although there were improvements in both the theory (paper #12) and fundamental interpretation (paper #16) of stopping of ultrathin films in general, the most progress by far was in predictive study of specific, paradigmatic systems.

Quantum size effects and the dramatic distinction between bulk and ultra-thin stopping in metal films were shown in the work on Li  $n$ -layers (paper #11). In particular, there is extremely slow convergence (with increasing  $n$ ) of the  $n$ -layer value of a property towards the bulk crystal value. In Li it appears that about 20 layers is needed to reach the bulk limit.

We also treated the effects of molecular vs. atomic-like ordering upon proton stopping in a large range of H  $n$ -layers (papers #5 and 7).

The archetypical ionic solid, LiF was studied in papers #13, 17, and 22. In the latter we showed that the 1-layer is an *indirect* gap material, in marked contrast with the crystal. Paper #13 treated the stopping at zero intraplanar strain, while #22 showed, surprisingly, that ionic 1-L stopping is so dominated by ionic binding that no qualitative change occurs for strains even as large as needed to attain gap closure and metallization.

A study of stopping in the graphite and diamond n-layers (paper #18) showed that the ratio of stopping for n-layers of the two C allotropes differs from the bulk ratio up through  $n = 4$  at least, once again demonstrating the critical importance of multiple length scales.

3. Calculation of the stopping and electronic properties of molecules continued, with particular emphasis on the variation of those properties with molecular geometry and with orientation.

From the directional dependence of the dipole oscillator strength distribution (DOSD), we showed (papers #2, 3, 4 and 9) that the stopping of protons of energies above 100 keV is dependent on the orientation of the target molecule. This behavior could be of use in films and bulk as well, and, perhaps, gives a clue for interpreting the ordering of stopping in certain hydrogen films (paper #5). In addition, the geometric dependence of the mean excitation energy can be related to temperature and isotope effects (papers #14 and 21), both of which are small in molecules, the latter being only a small fraction of the former. We would expect that the same would hold in thin films and in bulk targets.

4. In an effort to move toward absolutely first-principles calculation of stopping and other energy deposition phenomena, we have attempted first Born approximation stopping calculations for some small atoms directly from the generalized oscillator strength distribution (GOSD). The procedure is to generate the GOSD for the atom directly from the polarization propagator, then obtain the stopping directly by integration of the GOSD (papers #8 and 23). The outcome is in fact an illustration of the current state of the art: the scheme can be made to work for He but not for Be.

## References and Papers Acknowledging Support from the Present Contract Period

1. J. Oddershede and J.R. Sabin, "Polarization Propagator Calculations of Spectroscopic Properties of Molecules," *Int. J. Quantum Chem.* **39**, 371 (1991).
2. P. Jensen, J. Oddershede and J.R. Sabin, "Geometric Dependence of the Mean Excitation Energy and Spectral Moments of Water," *Phys. Rev. A* **43**, 4040 (1991).
3. G.H.F. Dierksen, J. Oddershede, I. Paidarova and J.R. Sabin, "Calculation of the Isotropic and Anisotropic Spectral Moments of the Dipole Oscillator Strength Distribution of  $N_2$ ," *Int. J. Quantum Chem.* **39**, 755 (1991).
4. J. Geertsen, J. Oddershede and J.R. Sabin, "Quadrupole Polarizability and Spectral Moments of the Quadrupole Oscillator Strength Distribution of  $N_2$ ," *Mol., Phys.* **72**, 1267 (1991).
5. J.Z. Wu, S.B. Trickey, J.R. Sabin and D.E. Meltzer, "Stopping of Swift Projectiles in Material Thin Films: Hydrogen," *Nucl. Instr. and Meth.* **B56/57**, 340 (1991).
6. J.R. Sabin and J. Oddershede, "Status of the Calculation of the Energy Loss of Swift Ions in Molecules," *Nucl. Instr. and Meth.* **B64**, 678 (1992).
7. J.Z. Wu, S.B. Trickey, J.R. Sabin and J.C. Boettger, "Structure, Energetics, and Molecular-to-Atomic-Ordering Transitions in Hydrogen Thin Films," *Phys. Rev. B* **45**, 8610 (1992).
8. E.H. Mortensen, J. Oddershede and J.R. Sabin, "Polarization Propagator Calculations of Generalized Oscillator Strengths and Stopping Cross Sections of He," *Nucl. Instr. and Meth.* **B69**, 24 (1992).

9. S.P.A. Sauer, J.R. Sabin and J. Oddershede, "Directional Characteristics of the Moments of the Dipole-Oscillator-Strength Distribution of Molecules:  $H_2$  and  $H_2O$ ," *Phys. Rev.* **B47**, 1123 (1993).
10. W.A. Parkinson, J.R. Sabin and J. Oddershede, "On the Uncorrelated Reference for Calculation of Properties," *Theo. Chim. Acta* **86**, 167 (1993).
11. J.Z. Wu, S.B. Trickey and J.R. Sabin, "Proton Stopping in Ultrathin Lithium Films," *Nucl. Instr. and Meth.* **B79**, 206 (1993).
12. D.E. Meltzer, J.R. Sabin, S.B. Trickey and J.Z. Wu, "Density Decomposition Options in the Orbital Local Plasma Approximation," *Nucl. Instr. and Meth.* **B82**, 493 (1993).
13. J.Z. Wu, S.B. Trickey and J.R. Sabin, "Electronic Stopping Power for Protons in an LiF Monolayer," *Int. J. Quantum Chem.* **QC27**, 219 (1993).
14. J.R. Sabin, J. Oddershede and I. Paidarova, "An Estimate of the Temperature Dependence of the Stopping Cross Section in Molecular Targets," *Nucl. Instru. and Meth. B* **B93**, 161 (1994).
15. G.A. Aucar, J. Oddershede and J.R. Sabin, *Phys. Rev. A*, "Relativistic Extension of the Bethe Sum Rule," *Phys. Rev. A*, in press.
16. S.B. Trickey, J.Z. Wu and J.R. Sabin, "Materials Specificity, Quantum Length Scales, and Stopping Powers," *Nucl. Instru. and Meth. B* **B93**, 186 (1994).
17. J.I. Juaristi, J.Z. Wu, J.A. Nobel, S.B. Trickey and J.R. Sabin, "On the Metallization of the LiF Monolayer," *Solid State Comm.* **91**, 957 (1994).
18. J.Z. Wu, S.B. Trickey, J.R. Sabin and J.A. Nobel, "Energy Deposition of Protons in Allotropic Carbon Ultra-Thin Layers," *Int. J. Quantum Chem.* **QC28**, 299 (1994).
19. J.A. Nobel, J.R. Sabin and S.B. Trickey, "Theoretical Ion Implantation Profiles for Low Energy Protons under Channeling Conditions," *Int. J. Quantum Chem.* **QC28**, 283 (1994).
20. S.P.A. Sauer, J.R. Sabin and J. Oddershede, "Calculated Molecular Mean Excitation Energies for Stopping and Straggling," *Nucl. Instru. and Meth. B*, (submitted).
21. J.R. Sabin, I. Paidarova and J. Oddershede, "The Relative Importance of Temperature and Isotope Effects on the Dipole Oscillator Strength Distribution Of  $H_2$  in the Polarization Propagator Formalism," *Theoret. Chim. Acta* **89**, 375 (1994).
22. J.Z. Wu, S.B. Trickey, J.R. Sabin and J.C. Boettger, "Calculated Properties of a Prototypical Ionic Monolayer," *Phys. Rev. B*, in press.
23. J.A. Nobel, J. Oddershede, J.R. Sabin and S.B. Trickey, "Basis Set Limitations on the *ab Initio* Calculation of Stopping Cross Sections via Generalized Oscillator Strengths," *Phys. Rev. A*, to be submitted.
24. H.H. Andersen and J.R. Sabin, "Introduction" to the Topical Issue of *Nucl. Inst. and Meth. on Target Aggregation and Projectile Charge States*, *Nucl. Inst. and Meth.* **B93**, v (1994).
25. S.B. Trickey and J.R. Sabin, "Reply to: Note on Stopping Power and Statistics of Particle Penetration," *Nucl. Inst. and Meth.* **B95**, 480 (1995).
26. U. Birkenheuer, N. Rösch, S. B. Trickey, and J. Noffke, "Structural Optimization and d-band Holes in Cu Monolayers," *Z Phys. B* **83**, 267 (1991).
27. J. C. Boettger and S. B. Trickey, "Quantum Size Effects in Equilibrium Lithium Ultra-thin Layers," *Phys. Rev. B* **45**, 1363 (1992).
28. S. B. Trickey, F. Müller-Plathe, G. H. F. Diercksen, and J. C. Boettger, "Interplanar Binding

- and Lattice Relaxation in a Graphite Di-Layer," Phys. Rev. B **45**, 4460 (1992).
29. J. A. Nobel, S. B. Trickey, P. Blaha, and K. Schwarz, "Low-Pressure Crystalline Phases in Lithium," Phys. Rev. B **45**, 5012 (1992).
  30. J. C. Boettger, S. B. Trickey, and J. A. Nobel, "Comment on *Total Energy Calculations of Solid H, Li, Na, K, Rb, and Cs*," Phys. Rev. B **45**, 7503 (1992).
  31. S. B. Trickey, "The Status of Density Functional Theory for Chemical Physics," in *Conceptual Trends in Quantum Chemistry*, J.-L. Calais and E. S. Kryachko, eds. (Kluwer, Amsterdam, 1993) vol. 1, p. 87
  32. J. C. Boettger, U. Birkenheuer, N. Rösch, and S. B. Trickey, "Quantum Size Effects in Hexagonal Aluminum Films," *Internat. J. Quantum Chem.* **S28**, 675 (1994)

### Papers in press

1. A.C. Diz, Y. Öhrn and J.R. Sabin, "Dynamic Charge States and Energy Deposition of Swift Helium Ions in Neon," Nucl. Inst. and Meth. B, in press.
2. J.A. Nobel, J.R. Sabin and S.B. Trickey, "Simulation of Ion Implantation in Si for 0.25 keV H<sup>+</sup> under Channeling Conditions," Nucl. Inst. and Meth. B, in press.
3. G.A. Aucar, J. Oddershede and J.R. Sabin, "Relativistic Extension of the Bethe Sum Rule," Phys. Rev. A, in press.
4. J.Z. Wu, S.B. Trickey, J.R. Sabin and J.C. Boettger, "Calculated Properties of a Prototypical Ionic Monolayer," Phys. Rev. B, submitted.
5. H.H. Mikkelsen, J. Oddershede, J.R. Sabin and E. Bonderup, "Bethe Theory for Directional Dependence of Stopping in Molecules," Nucl. Inst. and Meth. B, in press.
6. S.P.A. Sauer, J.R. Sabin and J. Oddershede, "Calculated Molecular Mean Excitation Energies for Stopping and Straggling," Nucl. Inst. and Meth. B, in press.
7. S.P. Apell, J.R. Sabin and S.B. Trickey, "Approach to Bulk Behavior from Ultrathin Layered Systems Probed by Energy Deposition," Int. J. Quantum Chem., in press.
8. J.A. Nobel, J. Oddershede, J.R. Sabin and S.B. Trickey, "Basis Set Limitations on the *ab Initio* Calculation of Stopping Cross Sections via Generalized Oscillator Strengths," Phys. Rev. A, to be submitted.
9. J. C. Boettger and S. B. Trickey, "High Precision Calculation of Crystallographic Phase Transition Pressures for Al," Phys. Rev. B Rapid Communication, in press.
10. J. C. Boettger, U. Birkenheuer, N. Rösch, and S. B. Trickey, "Theoretical Investigation of Na Adsorption on the Al (111) Surface," Phys. Rev. B, in press.

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